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TRANSMITTAL **FORM** 

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Total Number of Pages in This Submission

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Application Number	10/581,622	
Filing Date	June 5, 2006	
First Named Inventor	David Thomas FORREST	
Art Unit	1774	
Examiner Name		
Attorney Docket Number	52993/326894	

ENCLOSURES (check all that apply)						
Fee Transmittal F	orm	Drawing(s) (Figu	ure 2)	After Allowance Communication to Group		
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Amendment / Rep	oly	Petition			munication to Group e, Brief, Reply Brief)	
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Response to Missing Parts under 37 CFR 1.52 or 1.53						
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT						
Firm or Individual name	Bruce D. Gray, Reg. No. 35,799					
Signature	m					
Date	31 Oct 2006					

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APPLICANT:

David FORREST, et al.

SERIAL NO.:

10/581,622

Group Art Unit:

1774

FILED:

June 5, 2006

**EXAMINER:** 

FOR:

FREE-STANDING SILICON CARBIDE ARTICLES FORMED BY CHEMICAL VAPOR DEPOSITION AND METHODS FOR THEIR MANUFACTURE

ATTORNEY DOCKET NO.: 52993/326894

DATE:

10/31/06

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## INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with Rules 56, 97 and 98 of the Rules of Practice in Patent Cases (37 C.F.R. §§ 1.56, 1.97, and 1.98), the publications listed on the modified Form PTO/SB/08 are cited for consideration by the Examiner. Copies of the non-U.S. patent documents and other literature are submitted with this paper.

Submission of the references provided in this Information Disclosure is not intended to constitute an admission that any reference referred to herein is prior art for this invention unless specially designated as such. Also, in accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 C.F.R. § 1.56(a) exists.

U.S. Patent Application Serial No. 10/581,622

Filed: June 5, 2006

INFORMATION DISCLOSURE STATEMENT

This Information Disclosure Statement is being filed pursuant to 37 C.F.R. 1.97(b), before issuance of a first Office action on the merits. Applicant believes that no fee is due for

submission and consideration of this paper. The Commissioner is authorized to charge any fees

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Respectfully submitted,

Bruce D. Gray

Reg. No. 35,7992

KILPATRICK STOCKTON LLP Suite 2800, 1100 Peachtree Street Atlanta, Georgia 30309-4530 (404) 815-6218

PTO/SB/08A (10-01)

Van Zile, et al.Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE eduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known INFORMATION DISCLOSURE **Application Number** 10/581,622 STATEMENT BY APPLICANT Date Filed: June 5, 2006 First Named Inventor **David FORREST Group Art Unit** 1774 (use as many sheets as necessary) **Examiner Name** Attorney Docket Number of 2 52993/326894 Sheet

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		US-4,997,678	03/0	5/1991		Taylor, et al.		
<del></del>		US-5,098,631	03/2	4/1992		Pyzik, et al.		
		US-5,604,151	02/1	8/1997		Goela, et al.		
	_	US-5,612,132	03/1	8/1997		Goela, et al.		
		US-6,042,758	03/2	8/2000		Goela		
		US-6,228,297	05/0	8/2001		Goela, et al.		
		US-6,231,923	05/1	5/2001	Te	verovsky, et al.		
	<del></del>	US-6,464,912	10/1	5/2002		Goela, et al.		
····	•	US-20010022408 A1	09/2	0/2001		Goela, et al.		
1		US-20020004444 A1	01/1	0/2002		Goela, et al.		
1		US-2003/036471 A1	02-2	0-2003		Goela		
		US-2005/0123713 A1	06-0	9-2005		Forrest		
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		E P 1 127955 A1		08-29-2	2001	Shipley Compan LLC	у	
	<u> </u>	EP 0 955 278 A2		11-10-	1999	CVD Incorporate		
		EP 0 588 479 A1		03-23-	1994	CVD Incorporate		
		WO 99/41773		08-19-	1999	Applied Materials Inc.	5,	

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PTO/SB/08A (10-01)

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## STATEMENT BY APPLICANT

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Application Number 10/581,622 June 5, 2006 Date Filed: **David FORREST** First Named Inventor 1774 Group Art Unit **Examiner Name** Attorney Docket Number 52993/326894

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		Collins, et al., 'Investigation of CVD β-SiC Surfaces Produced via a 'Novel' Surface Replication Process,' <i>Mat. Res. Soc. Symp. Proc.</i> , 168:193-198 (1990)			
		Collins, et al., 'Grain size dependence of the thermal conductivity of polycrystalline chemical vapor deposited β-SIC at low temperature,' J. Appl. Phys., 68(12):6510-6512 (1990)			
		Goela and Taylor, 'Chemical Vapor Deposition for Silicon Cladding on Advanced Ceramics,' J. Am. Ceram. Soc., 72(9):1747-1750 (1989)			
		Kim and Zangvil, 'Microstructure Comparison of Transparent and Opaque CVD SiC,' J. Am. Ceram. Soc., 78(6):1571-1579 (1995)			
		Qadri, et al., 'Characteristics of Plasma Processed SiC Nanocrystallites and Nanorods,' Applied Physics Letters, American Institute of Physics, 83(3):548-550 (July 21, 2003)			

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